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Rib Data Sheet

CONFIRMATION NO. 8651

SERIAL NUMBER 10/060,569	FILING DATE 01/29/2002 RULE	CLASS 438	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. N230500C1
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APPLICANTS

Migaku Kobayashi, Tokyo, JAPAN;

**** CONTINUING DATA *******

THIS APPLICATION IS A CON OF 09/640,959 08/16/2000

now abandoned
1gpg 4-021

**** FOREIGN APPLICATIONS *******

JAPAN 230500/1999 08/17/1999

gpg 4-021

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/28/2002

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance 4-021				
Verified and Acknowledged	Examiner's Signature 4-021	Initials			

ADDRESS

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TITLE

Method of fabricating a semiconductor device

FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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